

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Application of:) Group Art Unit: 1765
Naoaki YAMAGUCHI et al.) Examiner: Anita Karen Alanko
Based on Serial No. 10/035,441)
Filed: January 4, 2002)
For: OPTICAL PROCESSING)
APPARATUS AND OPTICAL)
PROCESSING METHOD)

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents
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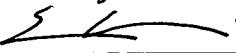
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application.

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, which waives the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

The references listed on the attached Form PTO 1449 were cited in parent application Serial No. 10/035,441 and predecessor Application Serial Nos. 09/547,716 and 08/451,648 and copies of the references can be found in those applications.

Respectfully submitted,


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Substitute for form 1449A/PTO				<i>Complete if Known</i>	
				Application Number	Based on SN 10/035,441
				Filing Date	Filed: January 4, 2002
				First Named Inventor	Naoaki YAMAGUCH et al.
				Group Art Unit	1765
				Examiner Name	Anita Karen Alanko
Sheet	1	of	3	Attorney Docket Number	0756-7191

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		5,808,318		Masumo et al.	09/15/1998	
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		Office ³	Number ⁴	Kind Code ³ (if known)				
		JP	05-243576			09/21/1993		Abst.
		JP	08-051078			02/20/1996		Abst.
		JP	06-204132			07/22/1994		Abst.

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS							
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		F. Ueno "Observation of fast microscopic phase change phenomena of chalcogenide thin films," Japanese Journal of Applied Physics, Supplement, Vol. 26, Supplement 26-4, pp. 55-60, 1987.					
		N. Kondo et al., "Film thickness measurement of ultrathin film using light of UV wavelength," Proceedings of the SPIE, Vol. 1673, pp. 392-402, 1992.					

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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		A.V. Dvurechenskii et al., "Transport Phenomena in Amorphous Silicon Doped by Ion Implantation of 3d Metals," USSR, pp. 635-640, Phys. Stat. Sol. (A) Vol. 95, 1986.	
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		R. Kakkad, G. Liu, S.J. Fonash, "Low Temperature Selective Crystallization of Amorphous Silicon," Journal of Non-Crystalline Solids, Volume 115, (1989), pp. 66-68.	

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